

<b>Notice of References Cited</b>	Application/Control No. 10/708,837	Applicant(s)/Patent Under Reexamination BEENAU ET AL.	
	Examiner Daniel I. Walsh	Art Unit 2876	Page 1 of 1

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*	B	US-6,609,656	08-2003	Elledge, Dennis D.	235/382
*	C	US-2005/0211784	09-2005	Justin, Antony Manoj	235/492
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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